

PROCEEDINGS OF SPIE

Optoelectronic Devices and Integration VII

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Editors

11–13 October 2018
Beijing, China

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Published by
SPIE

Volume 10814

Proceedings of SPIE 0277-786X, V. 10814

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Optoelectronic Devices and Integration VII, edited by Xuping Zhang, Baojun Li, Changyuan Yu, Xinliang Zhang,
Proc. of SPIE Vol. 10814, 1081401 · © 2018 SPIE · CCC code 0277-786X/18/\$18 · doi: 10.1117/12.2520909

Proc. of SPIE Vol. 10814 1081401-1

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Please use the following format to cite material from these proceedings:

Author(s), "Title of Paper," in *Optoelectronic Devices and Integration VII*, edited by Xuping Zhang, Baojun Li, Changyuan Yu, Xinliang Zhang, Proceedings of SPIE Vol. 10814 (SPIE, Bellingham, WA, 2018) Seven-digit Article CID Number.

ISSN: 0277-786X
ISSN: 1996-756X (electronic)

ISBN: 9781510622265
ISBN: 9781510622272 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

SPIE.org

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